## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re a	pplication of:	
	Mukai et al.	Examiner: Turocy, David P.
Applie	eation No: 09/910,583	) Art Unit: 1792
• •	•	Atty Docket No.: 005047/DSM/PMD/JW
Filed:	July 20, 2001	) Confirmation No.: 1386
For:	METHOD FOR FORMING INTERLAYER INSULATING FILM IN A SEMICONDUCTOR MANUFACTURING METHOD	) )
P.O. E	ant Commissioner For Patents Box 1450 ndria, VA 22313-1450	

## INFORMATION DISCLOSURE STATEMENT

In accordance with Applicant's duty of disclosure, enclosed is a copy of IDS citation Form PTO/SB/08 or PTO-1449, together with copies of the documents cited on that form, except for copies not required to be submitted (e.g., copies of U.S. patents and U.S. published patent applications need not be enclosed). It is respectfully requested that the cited reference be placed in the file.

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

representation	on that a search has been made in the subject application and is not to
an admissio	n that the information cited in this statement is material to patentabili
hereby certify the EFS Web on the d	at this correspondence is being deposited via ate below:
April 21, 2009	
	Date of Deposit
Gigi Hoover/	
Gigi Hoover	**************************************

Application No.: 09/910,583 Atty. Docket No.: 005047/DSM/PMD/JW

The Commissioner is authorized to charge any deficiencies or credit any overpayments in connection with this submission to Deposit Account No. 02-2666, and is requested to notify us of same.

Respectfully submitted, BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN, LLP

Date: April 21, 2009 /Justin K. Brask/

Justin K. Brask, Reg. #61,080

Blakely, Sokoloff, Taylor & Zafman LLP 1279 Oakmead Parkway Sunnyvale, CA 94085-4040 Telephone: (503) 439-8778

Facsimile: (503) 439-6073